

Title (en)
FORMATION OF SILICON NANOSTRUCTURES

Title (de)
BILDUNG VON SILICIUM-NANOSTRUKTUREN

Title (fr)
FORMATION DE NANOSTRUCTURES EN SILICIUM

Publication
EP 1628908 A4 20070801 (EN)

Application
EP 04707340 A 20040202

Priority

- NZ 2004000020 W 20040202
- NZ 52392103 A 20030131
- NZ 52392203 A 20030131

Abstract (en)
[origin: WO2004067445A1] The present invention comprises a method of forming nanostructures on a silicon substrate including the steps of in a chamber heating the substrate with an electron beam to a peak temperature, holding the peak temperature for a predetermined time, and decreasing the temperature of the substrate. Neon and carbon ions may be implanted into the substrate before the step of heating the substrate to produce different nanostructures. Implanting with nitrogen before heating prevents the formation of nanostructures. Plasma immersion ion implantation with nitrogen ions before heating also forms nanostructures.

IPC 8 full level
B81C 1/00 (2006.01); **B82B 3/00** (2006.01); **H01L 21/265** (2006.01); **H01L 21/324** (2006.01); **H01L 21/00** (2006.01)

CPC (source: EP US)
B81C 1/00111 (2013.01 - EP); **B82Y 30/00** (2013.01 - EP); **H01L 21/26506** (2013.01 - EP US); **H01L 21/324** (2013.01 - EP)

Citation (search report)

- [X] GB 2287825 A 19950927 - UNIV SURREY [GB]
- [A] EP 0969126 A2 20000105 - JP NATIONAL RESEARCH INST FOR [JP]
- [A] LU M L: "THERMAL REGROWTH OF SILICON(111) SURFACE DURING ION BOMBARDMENT", APPLIED PHYSICS LETTERS, AIP, AMERICAN INSTITUTE OF PHYSICS, MELVILLE, NY, US, vol. 40, no. 11, June 1982 (1982-06-01), pages 986 - 987, XP000817120, ISSN: 0003-6951
- See references of WO 2004067445A1

Designated contracting state (EPC)
AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HU IE IT LI LU MC NL PT RO SE SI SK TR

DOCDB simple family (publication)
WO 2004067445 A1 20040812; AU 2004207125 A1 20040812; EP 1628908 A1 20060301; EP 1628908 A4 20070801

DOCDB simple family (application)
NZ 2004000020 W 20040202; AU 2004207125 A 20040202; EP 04707340 A 20040202